JC831 U.S. PTO
09/586492
06/02/00

ISSUE CLASSIFICATION	
Class	Subclass
250	492.2

C RB

PATENT NUMBER
6323497
6323497

JC2
J&830

U.S. **UTILITY** Patent Application

O.I.P.E.	PATENT DATE
KW SCANNED _____ Q.A. A.G.	NOV 27 2001

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/586492		438	14	2812	Stevenson

APPLICANTS: Steven Walther

TITLE: Method and apparatus for controlling ion implantation during vacuum fluctuation

PTO-2040
12/99

ISSUING CLASSIFICATION

ORIGINAL		CROSS REFERENCE(S)	
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)
250	492.21	250	492.1
INTERNATIONAL CLASSIFICATION			
C 2 1 G	5/10		

☐ Continued on Issue Slip Inside File Jacket

☐ TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
	4	4	1	15	2
☐ The term of this patent subsequent to _____ (date) has been disclaimed.	Ambie Stephen 6-15-01 (Assistant Examiner) (Date)			NOTICE OF ALLOWANCE MAILED	
☐ The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____	John F. Niebling Supervisory Patent Examiner Technology Center 2800 6/25/01 (Primary Examiner) (Date)			7-2-01	
				ISSUE FEE	
				Amount Due $1240.00	Date Paid 10-9-01
☐ The terminal ____months of this patent have been disclaimed.	V Wannall 7/9/01 (Legal Instruments Examiner) (Date)			ISSUE BATCH NUMBER 155	

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